Docket No. N1085-00224 Inventor: Wang Hsiang Wei "Method For Combining Via Patterns Into A Single Mask" Sheet 1 of 1

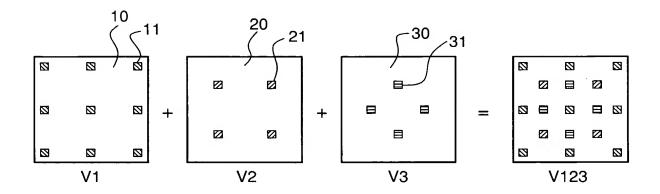
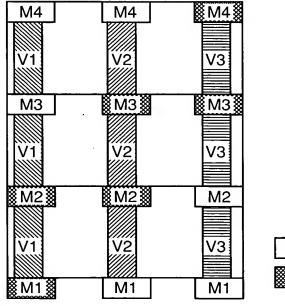


FIG. 1



Mx: Dummy metal line

Mx: Function metal line

FIG. 2